

MICRO-530

**Nanotechnology**

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Cursus	Sem.	Type
Microtechnics	MA2, MA4	Opt.
Minor in Quantum Science and Engineering	E	Opt.
Neuro-X minor	E	Opt.
Neuro-X	MA2, MA4	Opt.
Quantum Science and Engineering	MA2, MA4	Opt.

Language of teaching	English
Credits	3
Session	Summer
Semester	Spring
Exam	Oral
Workload	90h
Weeks	14
<b>Hours</b>	<b>3 weekly</b>
Courses	3 weekly
<b>Number of positions</b>	

**Summary**

This course gives the basics for understanding nanotechnology from an engineer's perspective: physical background, materials aspects and scaling laws, fabrication and imaging of nanoscale devices.

**Content****Nanometer scale phenomena.**

Basic understanding of some physical and chemical phenomena relevant at nanoscale.

- Basics of quantum mechanics
- Atomic structure (hydrogen like atoms)
- Molecular structure (linear combination of atomic orbitals)
- Band structure of solids in 0D, 1D, 2D, 3D (electrons in a box and in a periodic potential).
- Intermolecular forces
- Physi- and chemi-absorption
- Surface tension
- Examples of nanoscale phenomena: tunneling current, conductance quantization, Coulomb blockade, single electron transistor (SET), nanomagnetism, quantum Hall effect, Casimir effect.

**Nanometer scale fabrication and imaging.**

Overview of established and advanced methods to manufacturing nanopatterns and devices, as well as techniques to view nanoscale objects.

- Nanolithography for R&D prototyping (e.g. scanning probes, focused beam methods, stamp based replication, self-assembly)
- Nanolithography for industry (scalable projection lithography, nanoimprint lithography)
- Nanoscale imaging (optical methods, charged beam methods, scanning probe methods)

**Keywords**

- Nanotechnology
- quantum phenomena
- materials
- nanofabrication
- lithography
- fluidics
- self-assembly

- materials properties
- characterisation
- microscopy
- nanoprobes

## Learning Prerequisites

### Required courses

- Physics
- Basics of electromagnetism

### Recommended courses

- Fundamentals of Microfabrication (MT 3rd year, or MOOC)
- Chemistry (basics)

## Learning Outcomes

- Define the quantum physics origin of nanoscale effects
- Discriminate between different mechanisms influencing properties of nanomaterials and nanostructures and the involved length scales
- Describe the principal methods for nanomaterials synthesis
- Derive the principal nanofabrication techniques
- Derive interactions between nano-scale objects
- Synthesize the effects of quantum physics on nano-scale physicochemical properties
- Compare the different available methods for nanostructure characterisation & observation, as well as their advantages/disadvantages
- Propose a nanoimaging method and nanofabrication technique and process optimisations

## Transversal skills

- Access and evaluate appropriate sources of information.
- Assess one's own level of skill acquisition, and plan their on-going learning goals.
- Use a work methodology appropriate to the task.

## Teaching methods

Ex-cathedra course

## Expected student activities

Actively participate during class in Q&A

## Assessment methods

Oral exam

## Supervision

Office hours                      Yes

Assistants	No
Forum	Yes

## Resources

### Bibliography

#### Books

K. S. Krane, Modern Physics, John Wiley & Sons Inc, 2012.

P. Atkins, J. de Paula, Atkins' physical chemistry, Oxford Univ. Press, 2006.

J. N. Israelachvily, Intermolecular and surface forces, Academic Press, 2011.

#### Web resources

E. F. Schubert, Physical foundation of solid state devices,  
<http://homepages.rpi.edu/~schubert/>

### Ressources en bibliothèque

- [Intermolecular and surface forces / Israelachvill](#)
- 
- [Atkins' physical chemistry / Atkins, Paula](#)
- [Modern Physics / Krane](#)

### Notes/Handbook

Slides of the course available in Moodle:

<https://go.epfl.ch/MICRO-530>

### Websites

- <https://www.edx.org/course/micro-nanofabrication-mems-epflx-memsx-0>

### Moodle Link

- <https://go.epfl.ch/MICRO-530>